

# Effect of Al oxide top coatings on the durability of thermochromic $VO_2$ thin films

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Yu-Xia Ji, Shu-Yi Li, Gunnar A. Niklasson, Claes G. Granqvist Department of Engineering Sciences, The Ångström Laboratory, Uppsala University Box 534, SE-751 21 Uppsala, Sweden

# MOTIVATION

• VO<sub>2</sub> undergoes metal-to-insulator (rutile phase to monoclinic phase) transition at a critical temperature,  $\tau_c$ , about 68 °C

• It is a thermochromic (TC) material for energy-efficient window coating

(Modulation of the infrared transmittance of solar energy)

• Performance needs to be improved for practical use

## RESULTS

The AI oxide prevents oxidation of the underlying VO<sub>2</sub> both in high temperature environment (300  $^{\circ}$ C) (Fig. 2) and also in humidity condition (60  $^{\circ}$ C, RH= 95  $^{\circ}$ ) (Fig. 3) since the optical data are almost unchanged.

For the thinner AI oxide layer (10 nm), it gives good preservation of the TC properties up to  $t_h = 30$  h in the hot air (Fig. 2 (a) and (b)) and up to  $t_h$ = 72 h in the humidity condition (Fig. 3 (a) and (b)). The thicker Al oxide coating (30 nm) gives better durability.





## OBJECTIVE

The VO<sub>2</sub>-based films will lose their desirable properties during extended periods of time (Fig. 1) since  $VO_2$  is not the thermodynamically stable oxide  $(V_2O_5)$ .

**Fig. 2.** Spectral transmittance for 80-nm-thick VO<sub>2</sub> films, coated with 10 nm (panels a and b) and 30 nm of AI oxide (panels c and d), in as-deposited state and after heating at 300  $^{\circ}$ C in dry air for the shown durations  $t_h$ . Data were taken at  $\tau < \tau_c$  (panels a and c) and  $\tau > \tau_c$  (panels b and d).





The goal of this project is to preserve the thermochromism in  $VO_2$ -based materials by AI oxide top coating.



**Fig. 1.** Spectral transmittance for an 80-nm-thick VO<sub>2</sub> film in as-deposited state and after heating at 300  $^{\circ}$ C in dry air for one hour. Data were taken at  $\tau < \tau_c$  (panel a) and  $\tau > \tau_c$  (panel b).

## METHODOLOGY

Fig. 3. Spectral transmittance for 80-nm-thick VO<sub>2</sub> films, coated with 10 nm (panels a and b) and 30 nm of AI oxide (panels c and d), in as-deposited state and after heating at 60  $^{\circ}$ C in air with a relative humidity of 95 % for the shown durations  $t_h$ . Data were taken at  $\tau < \tau_c$  (panels a and c) and  $\tau > \tau_c$  (panels b and d).

## CONCLUSIONS

• 80-nm-thick VO<sub>2</sub> films rapidly converted to non-TC V<sub>2</sub>O<sub>5</sub> under the chosen harsh conditions.

A 30-nm-thick sputter-deposited AI oxide top coating provided good protection and delayed the oxidation for more than one day upon heating in dry air at 300 °C and that protection occurred for several days at 95 % relative humidity and 60 ℃.

•Thin films of VO<sub>2</sub> were prepared by reactive DC magnetron sputtering on 1-mm-thick glass plates. Al oxide films with thickness in the 10 to 150 nm range were deposited onto  $VO_2$ films.

•Films of VO<sub>2</sub> with and without Al oxide top layers, were subjected to two accelerated aging tests: thermal oxidative and humidity conditions.



 Increased thickness of the AI oxide yielded enhanced protection.

## REFERENCES & ACKNOWLEDGEMENTS

Y-X Ji, S-Y Li, G. A. Niklasson, C. G. Granqvist, *Thin Solid Films*, in press, http://dx.doi.org/10.1016/j.tsf.2014.03.043

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